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**OFFICIAL** PATENT  
MIC04 P-106

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Examiner : G. Goudreau  
Group : 1763  
Applicant : Imad Mahawili, PhD  
Serial No. : 09/488,309  
Filed : January 20, 2000  
For : REACTOR WITH REMOTE PLASMA SYSTEM AND  
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Dear Sir:


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Petition and Fee for Extension of Time (in duplicate); and  
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on December 17, 2003.

  
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Enclosures